Sir:

Transmitted herewith for filing is the Utility patent application of:

HAN-CHAO LAI, HUNG-SUI LIN AND TAO-CHENG LU INVENTOR (S):

METHOD FOR FORMING A METAL OXIDE SEMICONDUCTOR FOR

FOR:	TYPE FIELD EFFECT TRANSISTOR
Enclose	d are:
\boxtimes	14 page(s) of Specification, Claims and Abstract
X	6 sheet(s) of □ informal drawings
X	Declaration & Power of Attorney
	Claim of Priority under 35 U.S.C. 119
	Certified copy of
X	An assignment conveying title in instant application to MACRONIX INTERNATIONAL CO., LTD.
	with PTO Form 1595. $\sqrt{}$
	Preliminary Amendment
	Information Disclosure Statement

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ne filing fee is calculated as sho	NO. FILED		NO. EXTRA	RATE	AMOUNT	
Total Claims	18	MINUS 20	0	x \$18 =	\$	0.00
Independent Claims	2	MINUS 3	0	x \$ 80 =	\$	0.00
If multiple dependent claims are presented, add \$ 270.00						0.00
Basic Fee						
☐ Applicant claims small entity status. See 37 CFR 1.27. The fees indicated above are reduced by ½.						
Total of above calculations						
■ Assignment and Recording Fee						
Assignment and Recording				TOTAL FEE	\$	750.00

П	Please charge my Deposit Account Number	in the amount of	to cover	the filing	and	assignment
	recordation fees. A duplicate copy of this paper is encl	osed.				

 \boxtimes A credit card authorization for \$750.00 to cover the filing fees is enclosed.

The Commissioner is hereby authorized to charge any additional fees associated with this communication, including patent application filing fees and processing fees under 37 C.F.R. 1.16 and 1.17, or credit any overpayment to Deposit Account Number 07-1337.

Please forward all correspondence to Benjamin J. Hauptman.

Randy/A. Noranbrock

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